

View Online at <https://aerobasegroup.com/nsn/4820-01-569-1341>

Flow Control Device:

Disk

Disk Loading Method:

Weight

Maximum Operating Temp:

4000.0 degrees fahrenheit single response

End Application:

New construction lcs2

Valve Operation Method:

Automatic

Maximum Operating Pressure:

150.0 pounds per square inch single response

Product Name:

Wafer pattern check valve

Special Features:

Application: jp5; wafer style connections, raised, serrated face, cross bolted

Material:

Steel comp 316 flow control device

Media For Which Designed:

Fuel/oil, hydrocarbon single response

Style Designator:

Straight thru

Shelf Life:

N/a

Unit Of Measure:

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Demilitarization:

No

Fig:

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